

INVENTOR INFORMATION

Inventor One Given Name: Shuichi
Family Name: YABU
Postal Address Line One:
City of Residence: Kanagawa
State or Province of Residence: Kanagawa
Country of Residence: Japan
Citizenship Country: Japan

CORRESPONDENCE INFORMATION

Correspondence Customer Number: 05514
Fax: (212) 218-2200

APPLICATION INFORMATION

Title Line One: EXPOSURE APPARATUS, GAS REPLACING METHOD, AND
Title Line Two: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE

Total Drawing Sheets: 20
Formal Drawings?: Yes
Application Type: Utility
Docket Number: 35.G2760
Secrecy Order in Parent Appl.?: No

REPRESENTATIVE INFORMATION

Representative Customer Number: 5514

PRIOR FOREIGN APPLICATION

Foreign Application One: 2000-93687
Filing Date: 03-30-2001
Country: JAPAN
Priority Claimed: Yes